

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants: Date: February 14, 2008
Haight et al. Group Art Unit: 1793
Serial No.: 09/933,461 Examiner: Geoffrey S. Evans
Filed: August 20, 2001 Docket No.: YOR919980510US2
For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED 11/2/2007

Amendments to the claims begin on 2 page of this paper.

Remarks begin on 17 page of this paper.